



520.40997X00

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Y. SHIBATA, et al  
Serial No.: 10/020,977  
Filed: December 19, 2001  
For: METHOD AND APPARATUS FOR DETECTING DEFECTS  
Group: 2877  
Examiner: G. Stock, Jr.

**AMENDMENT**

Mail Stop: Amendment (Fee)  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

August 22, 2005

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, in response to the Office Action dated April 20, 2005. The amendments are listed below and set forth on the following pages.

Amendment of the Claims;

Remarks are included following the amendments.